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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2826
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Koichi OHTO, et al.
Appln. No.: 10/650,193
Confirmation No.: 6245
Filed: August 28, 2003
For: SEMICONDUCTOR DEVICE HAVING SILICON-DIFFUSED METAL WIRING LAYER AND ITS MANUFACTURING METHOD

Docket No: Q77191
Group Art Unit: 2826
Examiner: Alexander O. WILLIAMS

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 1, 2006, please amend the above-identified application as follows on the accompanying pages.

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